S/N 09/135,413   PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:.   Leonard Forbes et al.   Examiner: Viet Q. Nguyen

Serial No.:   09/135,413   Group Art Unit: 2818

Filed: August 14, 1998   Docket: 303.354US2

Title: METHOD FOR OPERATING A DEAPROM HAVING AN AMORPHOUS
              SILICON CARBIDE GATE INSULATOR

INFORMATION DISCLOSURE STATEMENT

Box RCE
Assistant Commissioner for Patents
Washington, D.C. 20231

In compliance with the duty imposed by 37 C.F.R. § 1.56, and in accordance with 37

C.F.R. §§ 1.97 *et. seq.*, the enclosed materials are brought to the attention of the Examiner for

consideration in connection with the above-identified patent application. Applicants respectfully

request that this Information Disclosure Statement be entered and the documents listed on the

attached Form 1449 be considered by the Examiner and made of record. Pursuant to the provisions

of MPEP 609, Applicants request that a copy of the 1449 form, initialed as being considered by the

Examiner, be returned to the Applicants with the next official communication.

Pursuant to 37 C.F.R. §1.97(b), it is believed that no fee or statement is required with the

Information Disclosure Statement.

The Examiner is invited to contact the Applicants' Representative at the below-listed

telephone number if there are any questions regarding this communication.

Respectfully submitted,

LEONARD FORBES ET AL.

By their Representatives,

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Date 22 May 2002   By

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